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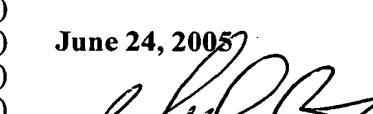
PATENT
Docket No. 20063/OG03-046

**IN THE UNITED STATES PATENT
AND TRADEMARK OFFICE**

Applicant(s): **In Su KIM**
U.S. Serial No.: 10/758,188
For: "Methods of Fabricating Semiconductor Devices"
Filed: 1/15/2004
Group Art Unit: 2811
Examiner: Not Yet Assigned

) I hereby certify that this paper and the documents referred to as enclosed therewith are being deposited with the United States Postal Service as first class mail, postage prepaid, in an envelope addressed to Commissioner for Patents, P.O. Box 1450, Alexandria, Virginia 22313-1450 on this date:

) **June 24, 2005**

) 
Mark C. Zimmerman
Attorney for Applicant(s)
Registration No. 44,006

STATUS LETTER

Commissioner for Patents
P.O. Box 1450
Alexandria, Virginia 22313-1450

Sir:

Kindly advise when an Office action can be expected in the above-referenced matter.

Respectfully submitted,

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June 24, 2005

By:

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